

	Application No.	Applicant(s)
	10/710,260	LEE ET AL.
Notice of Allowability	Examiner	Art Unit
	Faye Boosalis	2884
The MAILING DATE of this communication appeal All claims being allowable, PROSECUTION ON THE MERITS IS (herewith (or previously mailed), a Notice of Allowance (PTOL-85) NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT RIC of the Office or upon petition by the applicant. See 37 CFR 1.313	OR REMAINS) CLOSED in this apport or other appropriate communication GHTS. This application is subject to	vill be mailed in due course. THIS
1. This communication is responsive to submission of 22 Sept	tember 200 <u>6</u> .	•
2. The allowed claim(s) is/are <u>1-20</u> .		
 3. Acknowledgment is made of a claim for foreign priority under a) All b) Some* c) None of the: Certified copies of the priority documents have Certified copies of the priority documents have Copies of the certified copies of the priority documents have International Bureau (PCT Rule 17.2(a)). * Certified copies not received:	been received. been received in Application No cuments have been received in this rec	national stage application from the complying with the requirements S AMENDMENT or NOTICE OF
(a) ☐ including changes required by the Notice of Draftsperso		948) attached
1) hereto or 2) to Paper No./Mail Date	· · · · · · · · · · · · · · · · · · ·	•
(b) ☐ including changes required by the attached Examiner's Paper No./Mail Date		office action of
identifying indicia such as the application number (see 37 CFR 1.8 each sheet. Replacement sheet(s) should be labeled as such in the	1 77	
6. DEPOSIT OF and/or INFORMATION about the depose attached Examiner's comment regarding REQUIREMENT F		
Attachment(s)		•
1. Notice of References Cited (PTO-892)	5. Notice of Informal Page 1	atent Application
2. Notice of Draftperson's Patent Drawing Review (PTO-948)	6. Interview Summary Paper No./Mail Date	
3. LJ Information Disclosure Statements (PTO/SB/08), Paper No./Mail Date	7. 🔲 Examiner's Amendn	nent/Comment
4. Examiner's Comment Regarding Requirement for Deposit of Biological Material	8. 🛛 Examiner's Stateme	nt of Reasons for Allowance
	9.	
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EXAMINER'S STATEMENT OF REASONS FOR ALLOWANCE

Comment on Submissions

- 1. This communication is responsive to submissions 22 September 2006.
- 2. Amendments to the Specification are accepted.

Allowable Subject Matter

- 3. Claims 1-20 are allowed.
- 4. The following is an examiner's statement of reasons for allowance:

Regarding independent claim 1, the prior art does not disclose or fairly suggest an optical sensor package comprising: a window located at the second surface so that infrared radiation passes through the wall of the substrate, through the cavity, and then to the optical sensing element.

The examiner notes that while it is known in the art of an optical system package comprising: a substrate in which a cavity is defined, a second surface opposite the first surface (12), and a wall (28) between the cavity (26) and the second surface, at least a portion of the substrate being formed of silicon; a membrane (14) bonded to the substrate and spanning the cavity (26) in the substrate (see for example Jack et al – US 5,689,087 A -- Fig. 1d and col. 3, lines 1-67, col. 4, lines 1-5, lines 36-50, lines 56-67 and col. 5, lines 1-4 and lines 10-14). The cavity (26) is only present during processing of the optical system package and the final package is completely filled with a radiation-absorbing region (28), formed of (multilayered Ti/Zn/Se structure) (col. 4, lines 51-60), the prior art does not suggest a backside illumination of an optical sensor package in

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which a cavity exists wherein radiation passes through the wall of the substrate, through the cavity, and then to the optical sensing element.

Regarding independent claim 14, the prior art does not disclose or fairly suggest an infrared sensor package comprising: a window located at the second surface so that infrared radiation passes through the wall of the substrate, through the cavity, and then to the thermopile sensing element.

The examiner notes that while it is known in the art of an infrared sensor package comprising: a substrate (12) having a first surface in which a cavity (26) is defined, a second surface opposite the first surface (12), and a wall (28) defined between the cavity (26) and the second surface, at least a portion of the substrate being formed of silicon; a membrane (14) bonded to the substrate and spanning the cavity (26) in the substrate (12); a thermopile sensing element (20) (22) (24) on the membrane (14); and integrated circuitry (16) on the substrate, the integrated circuitry performing logic functions and signal processing for the thermopile sensing element (20) (22) (24) (see for example Jack et al – US 5,689,087 A -- Fig. 1d and col. 3, lines 1-67, col. 4, lines 1-5, lines 36-50, lines 56-67 and col. 5, lines 1-4 and lines 10-14). The cavity (26) is only present during processing of the infrared sensor package and the final package is completely filled with a radiation-absorbing region (28), formed of (multilayered Ti/Zn/Se structure) (col. 4, lines 51-60), the prior art does not suggest a backside illumination of an optical sensor package in which a cavity exists wherein radiation passes through the wall of the substrate, through the cavity, and then to the thermopile sensing element. The remaining claims 2-13 and 15-20 are allowable based on its dependency.

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Conclusion

5. Any inquiry concerning this communication or earlier communications from the examiner should be directed to Faye Boosalis whose telephone number is 571-272-2447. The examiner can normally be reached on Monday thru Friday from 7:00 AM to 3:30 PM.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Dave Porta can be reached on 571-272-2444. The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300.

6. Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

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OTILIA GABOR
PRIMARY EXAMINER